Application/Control N	. Applicant(s)/Patent under Reexamination	
10/821,762	LEE, JUNG KI	
Examiner	Art Unit	
Lindsay M. Maguire	3634	

	SEARCHED					
Class	Subclass	Date	Examiner			
	As noted in Prior Action					
211						
180						
160		1/26/2006	LMM			

INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
		DATE	EXMR	
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